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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Attorney Docket No. 100176)**

First Inventor: Roland K. Sevilla

Serial No.: 10/601,601

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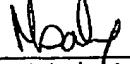
Title: POLISHING PAD FOR
ELECTROCHEMICAL-
MECHANICAL POLISHING

Examiner: Maurina T. Rachuba

Art Unit: 3723

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Mail Stop Amendment
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RESPONSE TO OFFICE ACTION

This is a reply to the Office Action mailed June 7, 2006 for the above captioned U.S. patent application.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 4 of this paper.

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